29A 3453

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Art Unit: 2834

SHOHEI SATO

Examiner: Thomas M. Dougherty

Serial No.: 10/620,094

Filed: 7/15/2003

For: ULTRASONIC PROBE AND

MANUFACTURING METHOD

THEREOF

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Mail Stop: Amendment

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, Applicant for the above-identified application hereby submits legible copies of the following relevant arts along with the FORM PTO-1449 which contains the information required by 37 CFR 1.98(b):

- A. European Patent Publication No. EP 1 132 978 published by the EPO on September 12, 2001;
- B. U.S. Patent Application Publication No. 2002/130590 of Seigo et al. published on September 19, 2002; and
- C. U.S. Patent Application Publication No. 2002/073781 of Hashimoto et al. published on June 20, 2002.

The above-listed prior art A-C are cited in the Search Report dated December 9, 2005 by the European Patent Office for European Patent Application No. EP 05 02 0237 which is a counterpart application to the above-identified U.S. application. A copy of the Search Report is enclosed.

Prior art A discloses insulation patterns 16, 23 corresponding to the vertical insulating layer of the present invention. The present invention differs from prior art A in the feature that a

pair of vertical insulating layers and a pair of vertical electrode layers are provided on a pair of side surfaces of the piezoelectric section body. Furthermore, prior art A nowhere mentions or suggests the "specified structures" defined in the claims of the present application.

It is, therefore, respectfully requested that the Patent Office make a record of these relevant art and consider them during the prosecution.

Respectfully submitted,

KODA & ANDROLIA

William L. Androlia Reg. No. 27,177

2029 Century Park East Suite 1140 Los Angeles, CA 90067-2983

Tel: (310) 277-1391 Fax: (310) 277-4118

Dated: March 3, 2006

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

Commissioner for Patents

P.O. Box 1450, Alexandria, VA 22313-1450, on

March 3, 2006

Date of Deposit

William L. Androlia

Mame-

3/3/2006

Signature Date

Docket Number (Optional) Application Number 29A 3453 10/620.094 **INFORMATION DISCLOSURE CITATION Applicant** IN AN APPLICATION Shohei Sato **Group Art Unit** Filing Date (Use several sheets if necessary) 2834 7/15/2003 **U.S. PATENT DOCUMENTS FILING DATE IF EXAMINER SUBCLASS** NAME **CLASS DOCUMENT NUMBER** DATE **APPROPRIATE** INITIAL 2002/130590 9/19/2002 Shiraishi 2002/073781 6/20/2002 Hashimoto **FOREIGN PATENT DOCUMENTS TRANSLATION** DATE COUNTRY CLASS **SUBCLASS DOCUMENT NUMBER** (YES/NO) 9/12/2001 **EPC** EP 1 132 978 OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) **EXAMINER DATE CONSIDERED** EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.